

**Search Notes**

Application/Control No.

10/711,111

Examiner

Jacob Y. Choi

Applicant(s)/Patent under  
Reexamination

HEITLAUF, VIVienne M.

Art Unit

2875

**SEARCHED**

Class	Subclass	Date	Examiner
362	103, 249, 806, 808, 396, 122	9/18/2006	JC
362	124, 396	9/18/2006	JC

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Class/Subclass (e.g, including class 24, 428, 446) & Text Search Conducted by Examiner	9/18/2006	JC